

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number 245402008300	Application Number Not Yet Assigned
	Applicant Nobuaki TERAGUCHI	
	Filing Date Concurrently Herewith	Group Art Unit Not Yet Assigned
	Mailing Date February 3, 2004	

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO
<i>12</i>	1.	05/11/1993	JP 5-291621	Japan			Abstract

OTHER DOCUMENTS

(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
<i>12</i>	2.	Ruvimov, S. et al. (1998). "Microstructure of Ti/Al Ohmic Contacts for n-AlGaIn," <i>Appl. Phys. Lett.</i> 73(18):2582-2584.

EXAMINER:

Nitin Parekh

DATE CONSIDERED:

04/20/05

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.